

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT** ( Not for submission under 37 CFR 1.99)

Application Number		10695620
Filing Date		2003-10-27
First Named Inventor	Alexander Kadyshevitch	
Art Unit	2881	
Examiner Name	David A. Vanore	
Attorney Docket Number	40006317-0045-552	

U.S.PATENTS						<a href="#">Remove</a>
Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
	1	4578279		1996-03-25	Zingher	
	2	4902964		1990-02-20	Lee	
	3	5150185		1992-09-22	Yamada	
	4	5637186		1997-06-10	Liu et al.	
	5	5736863		1998-04-07	Liu	
	6	5897710		1999-04-27	Sato et al.	
	7	5903011		1999-05-11	Hatanaka	
	8	6232787		2001-05-15	Lo et al.	

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number		10695620
Filing Date		2003-10-27
First Named Inventor	Alexander Kadyshevitch	
Art Unit		2881
Examiner Name	David A. Vanore	
Attorney Docket Number		40006317-0045-552

	9	6235634		2001-05-22	White et al.	
	10	6236222		2001-05-22	Sur Jr. et al.	
	11	6407386		2002-06-18	Dotan et al.	
	12	6410353		2002-06-25	Tsai	
	13	6559662		2003-05-06	Yamada et al.	
	14	6614244		2003-09-02	Yamada et al.	
	15	6897440		2005-05-24	Yamada	

If you wish to add additional U.S. Patent citation information please click the Add button.

Add

**U.S.PATENT APPLICATION PUBLICATIONS**

Remove

Examiner Initial*	Cite No	Publication Number	Kind Code <sup>1</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
	1	20010022345		2001-09-20	Isimoto	
	2	20020070738		2002-06-13	Yamada	

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number		10695620
Filing Date		2003-10-27
First Named Inventor	Alexander Kadyshevitch	
Art Unit	2881	
Examiner Name	David A. Vanore	
Attorney Docket Number	40006317-0045-552	

	3	20020093350		2002-07-18	Yamada	
	4	20020134936		2002-09-30	Miyako et al.	
	5	20030104639		2003-06-05	Kikuchi et al.	

If you wish to add additional U.S. Published Application citation information please click the Add button. [Add](#)

**FOREIGN PATENT DOCUMENTS**

[Remove](#)

Examiner Initial*	Cite No	Foreign Document Number <sup>3</sup>	Country Code <sup>2</sup>	Kind Code <sup>4</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T <sup>5</sup>
	1	JP 11087451			1999-03-30	Mitsubishi Electric Corp.		<input checked="" type="checkbox"/>
	2	JP 2000174077			2000-06-23	NEC Corporation		<input checked="" type="checkbox"/>
	3	JP 144155			2001-05-25	Matsushita Electronics Industry Corp.		<input type="checkbox"/>
	4	JP 2001338956			2001-07-12	NEC Corporation		<input type="checkbox"/>
	5	JP 2002083849			2002-03-23	NEC Corporation		<input type="checkbox"/>
	6	JP 2002231780			2002-08-16	Jeol Ltd.		<input type="checkbox"/>

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number	10695620
Filing Date	2003-10-27
First Named Inventor	Alexander Kadyshevitch
Art Unit	2881
Examiner Name	David A. Vanore
Attorney Docket Number	40006317-0045-552

7	WO 0180304		A2	2001-10-25	Klatencor Corporation		<input type="checkbox"/>
8	WO 03067653		A2	2003-08-14	Applied Materials, Inc.		<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button

**NON-PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>5</sup>
	1	International Search Report and Written Opinion for PCT/US2004/014450, September 28, 2004	<input type="checkbox"/>
	2	YACOBI et al., "Microanalysis of Solids", 1994 Plenum Press, New York, Chapters 1, 2 & 4.	<input type="checkbox"/>
	3	Model EKF-1000 Omnicron Nanotechnology GmbH, Taunusstein, Germany, Available at <a href="http://www.omnicron.de/products/ekf1000">http://www.omnicron.de/products/ekf1000</a> , 2002	<input type="checkbox"/>
	4	YAMADA, Keizo, "In-Line Contact and Via Hole Monitoring Method Used Electron-Beam-Induced Substrate Current (EB Scope), NEC Research and Development, Nippon Electric Ltd., Tokyo, Japan, vol. 41, no. 4, October 2000 (2000-10), pages 336-340, XP000967723, ISSN: 0547-051X	<input type="checkbox"/>
	5	Invitation to Pay Additional Fees, International Patent Application No. PCT/US03/03494, Applied Materials, Inc., August 19, 2003	<input type="checkbox"/>
	6	International Search Report, International Patent Application No. PCT/US03/03494, Applied Materials, Inc., November 28, 2003	<input type="checkbox"/>
	7	Written Opinion, International Patent Application No. PCT/US03/03494, Applied Materials, Inc., Applied Materials, Inc., January 27, 2005	<input type="checkbox"/>

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number	10695620
	Filing Date	2003-10-27
	First Named Inventor	Alexander Kadyshevitch
	Art Unit	2881
	Examiner Name	David A. Vanore
	Attorney Docket Number	40006317-0045-552

8	International Preliminary Examination Report, International Patent Application No. PCT/US03/03494, Applied Materials, Inc., August 19, 2003	<input type="checkbox"/>
---	---	--------------------------

If you wish to add additional non-patent literature document citation information please click the Add button

### EXAMINER SIGNATURE

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> See Kind Codes of USPTO Patent Documents at [www.USPTO.GOV](http://www.USPTO.GOV) or MPEP 901.04. <sup>2</sup> Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>3</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>4</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>5</sup> Applicant is to place a check mark here if English language translation is attached.

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number	10695620
Filing Date	2003-10-27
First Named Inventor	Alexander Kadyshevitch
Art Unit	2881
Examiner Name	David A. Vanore
Attorney Docket Number	40006317-0045-552

**CERTIFICATION STATEMENT**

Please see 37 CFR 1.97 and 1.98 to make the appropriate selection(s):

☐ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

**OR**

☐ That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(2).

☐ See attached certification statement.

☒ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.

☐ None

**SIGNATURE**

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/Tarek N. Fahmi/	Date (YYYY-MM-DD)	2006-09-08
Name/Print	Tarek N. Fahmi	Registration Number	41402

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1 hour to complete, including gathering, preparing and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

## Privacy Act Statement

The Privacy Act of 1974 (P.L. 93-579) requires that you be given certain information in connection with your submission of the attached form related to a patent application or patent. Accordingly, pursuant to the requirements of the Act, please be advised that: (1) the general authority for the collection of this information is 35 U.S.C. 2(b)(2); (2) furnishing of the information solicited is voluntary; and (3) the principal purpose for which the information is used by the U.S. Patent and Trademark Office is to process and/or examine your submission related to a patent application or patent. If you do not furnish the requested information, the U.S. Patent and Trademark Office may not be able to process and/or examine your submission, which may result in termination of proceedings or abandonment of the application or expiration of the patent.

The information provided by you in this form will be subject to the following routine uses:

1. The information on this form will be treated confidentially to the extent allowed under the Freedom of Information Act (5 U.S.C. 552) and the Privacy Act (5 U.S.C. 552a). Records from this system of records may be disclosed to the Department of Justice to determine whether the Freedom of Information Act requires disclosure of these records.
2. A record from this system of records may be disclosed, as a routine use, in the course of presenting evidence to a court, magistrate, or administrative tribunal, including disclosures to opposing counsel in the course of settlement negotiations.
3. A record in this system of records may be disclosed, as a routine use, to a Member of Congress submitting a request involving an individual, to whom the record pertains, when the individual has requested assistance from the Member with respect to the subject matter of the record.
4. A record in this system of records may be disclosed, as a routine use, to a contractor of the Agency having need for the information in order to perform a contract. Recipients of information shall be required to comply with the requirements of the Privacy Act of 1974, as amended, pursuant to 5 U.S.C. 552a(m).
5. A record related to an International Application filed under the Patent Cooperation Treaty in this system of records may be disclosed, as a routine use, to the International Bureau of the World Intellectual Property Organization, pursuant to the Patent Cooperation Treaty.
6. A record in this system of records may be disclosed, as a routine use, to another federal agency for purposes of National Security review (35 U.S.C. 181) and for review pursuant to the Atomic Energy Act (42 U.S.C. 218(c)).
7. A record from this system of records may be disclosed, as a routine use, to the Administrator, General Services, or his/her designee, during an inspection of records conducted by GSA as part of that agency's responsibility to recommend improvements in records management practices and programs, under authority of 44 U.S.C. 2904 and 2906. Such disclosure shall be made in accordance with the GSA regulations governing inspection of records for this purpose, and any other relevant (i.e., GSA or Commerce) directive. Such disclosure shall not be used to make determinations about individuals.
8. A record from this system of records may be disclosed, as a routine use, to the public after either publication of the application pursuant to 35 U.S.C. 122(b) or issuance of a patent pursuant to 35 U.S.C. 151. Further, a record may be disclosed, subject to the limitations of 37 CFR 1.14, as a routine use, to the public if the record was filed in an application which became abandoned or in which the proceedings were terminated and which application is referenced by either a published application, an application open to public inspections or an issued patent.
9. A record from this system of records may be disclosed, as a routine use, to a Federal, State, or local law enforcement agency, if the USPTO becomes aware of a violation or potential violation of law or regulation.